

DOCKET NO: 245156US3CIP

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF	:	
TSUTOMU OKABE, ET AL.	:	EXAMINER: MOORE, K.
SERIAL NO: 10/706,915	:	
FILED: NOVEMBER 14, 2003	:	GROUP ART UNIT: 1792
FOR: WAFER PROCESSING APPARATUS HAVING DUST PROOF FUNCTION	:	
		DO NOT ENTER: /KM/ (04/16/2008)

AMENDMENT UNDER 37 C.F.R. § 1.111

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated December 14, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.